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Applicant(s): Kwang Choe et al.

Examiner: Padgett, Marianne L.

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POROUS SILICON

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313

INFORMATION DISCLOSURE STATEMENT

Sir:


In accordance with 37 C.F.R §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. Japanese Published Unexamined Patent Application 2000-156484 published June 6, 2000 together with English language Abstract;
2. Japanese Published Unexamined Patent Application 2000-012481 published January 14, 2000 together with English language Abstract;
3. Japanese Published Unexamined Patent Application 2000-082679 published March 21, 2000 together with English language Abstract;

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on June 4, 2008.

Dated: June 4, 2008



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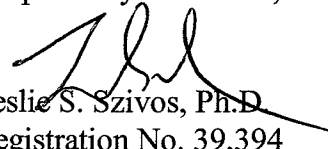
4. Japanese Published Unexamined Patent Application 62-108539 published May 19, 1987 together with English language Abstract;
5. Japanese Published Unexamined Patent Application 56-110247 published September 1, 1981 together with English language Abstract;
6. Japanese Published Unexamined Patent Application 56-056648 published May 18, 1981 together with English language Abstract
7. Japanese Published Unexamined Patent Application 61-180446 published August 13, 1986 together with English language Abstract;
8. U.S. Patent No. 5,950,094 issued September 7, 1999.

The references were cited in an Official Action dated March 4, 2008 received from the Japanese Patent Office. Applicants are submitting a copy of the above-cited references 1-7, together with English language Abstracts required by 37 C.F.R. §1.98(a)(2)(i) and (ii), together with a copy of the Office Action.

Further, the undersigned hereby states that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(b)(4), no statement or fee is required.

Respectfully submitted,


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